

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chun-Keng Hsu

Group Art Unit: 3652

Serial No.: 10/040,104

Examiner: Paul T. Chin

Filed: Oct. 19, 2001

In Response to Office Action

Dated: 0

Oct. 23, 2003

For:

WAFER BLADE EQUIPPED WITH PIEZOELECTRIC SENSORS

Attorney Docket No.: 67,200-531

## Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

kathy-Dixon.

Date: Jan. 23, 2004

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## RESPONSE TO OFFICE ACTION

Commissioner for Patents Alexandria, VA 22313-1450

Dear Sir:

In response to an Office Action mailed Oct. 23, 2003, please enter the following amendments and consider the following remarks.